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**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q77851

Hiroo TAKIZAWA, et al.

Appln. No.: 10/678,301

Group Art Unit: 1756

Confirmation No.: 4148

Examiner: Not Yet Assigned

Filed: October 06, 2003

For: NON-RESONANT TWO-PHOTON ABOORBING MATERIAL, NON-RESONANT TWO-PHOTON EMITTING MATERIAL, AND METHOD FOR INDUCING ABSORPTION OR GENERATING EMISSION OF NON-RESONANT TWO PHOTONS BY USING THE MATERIAL

**STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The undersigned respectfully requests to be advised of the status of the above-identified application.

Respectfully submitted,

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WASHINGTON OFFICE

**23373**

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Date: October 17, 2005